



OSMM&N File No. 251265US2RD DIV

Serial No. 10/816.929

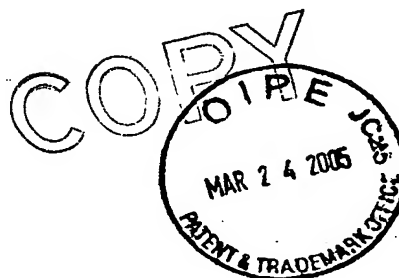
In the matter of the Application of: Masayuki ISHIKAWA, et al.

For: SEMICONDUCTOR DEVICE, SEMICONDUCTOR LASER, THEIR  
MANUFACTURING METHODS AND ETCHING METHODS

Due Date: N/A

The following has been received in the U.S. Patent Office on the date stamped hereon:

- Dep. Acct. Order Form
- Amendment Under 37 CFR §1.312
- Amendment Cover Letter



mlh

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Docket No. 251265US2RD DIV

IN RE APPLICATION OF: Masayuki ISHIKAWA, et al.

SERIAL NO: 10/816,929

FILED: April 5, 2004

ALLOWED: March 4, 2005

FOR: SEMICONDUCTOR DEVICE, SEMICONDUCTOR LASER, THEIR MANUFACTURING METHODS AND ETCHING METHODS

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:  
Transmitted herewith is an **Amendment Under 37 CFR §1.312** in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	8	MINUS	20	0	x \$50 =	\$0.00
INDEPENDENT	2	MINUS	3	0	x \$200 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of **\$0.00** is attached.
- ☐ Credit card payment form is attached to cover the fees in the amount of **\$0.00**
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,  
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DOCKET NO: 251265US2RD DIV



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

MASAYUKI ISHIKAWA ET AL

ALLOWED: MARCH 4, 2005

SERIAL NO: 10/816,929

EXAMINER: IGWE U. ANYA

FILED: APRIL 5, 2004

ART UNIT: 2829

FOR: SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR LASER, THEIR  
MANUFACTURING METHODS AD  
ETCHING METHODS

AMENDMENT UNDER 37 CFR §1.312

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to issuance, please amend the above-identified divisional application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

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